

Form PTO-1449					Docket No. P04,0300		Serial No. Notassigned	
INFORMATION DISCLOSURE CITATION IN AN APPLICATION (use several sheets if necessary)					Applicant Martin WIEDEMER		Group Art Unit Notassigned	
					Filing Date Herewith			
U.S. PATENT DOCUMENTS								
Examiner's Initials		Document Number	Date	Name	Class	Subclass	Filing Date If appropriate	
	AA	4,764,776	08/16/88	Mugrauer et al.				
	AB	5,067,404	11/26/91	Frunder et al.				
	AC	5,379,698	01/10/95	Nowak et al.				
	AD	6,016,750	01/25/00	Nüssel et al.				
	AE	6,180,213	01/30/01	Kuroki et al.				
	AF	6,204,875	03/20/01	De Loor et al.				
	AG	6,295,928	10/02/01	Heinzi et al.				
	AH	2001/0004265	21/06/01	Kurematsu				
	AI							
	AJ							
	AK							
	AKI							
FOREIGN PATENT DOCUMENTS								
		Document Number	Date	Country	Class	Subclass	Translation	
							Yes	No
	AL	38 21 268	12/28/89	Europe				
	AM	WO 97/36746	10/09/97	PCT				
	AN	0 746 470	10/22/97	Europe				
	AO	0 756 544	03/18/96	Europe				
	AP	WO 98/32608	07/30/98	PCT				
	AQ1	0 903 226	03/24/99	Europe				
	AQ2	WO 00/16988	03/30/00	PCT				
	AQ3	0 992 350	04/12/00	Europe				
	AQ4	WO 01/02170	01/11/01	PCT				
	AQ5	101 32 204	01/30/03	Germany				
	AQ6							
OTHER PRIOR ART (Including Author, Title, Date, Pertinent Pages, Etc.)								
	AR	Patent Abstracts of Japan 59008473 01/17/84						
	AS	Patent Abstracts of Japan 63015270 01/22/88						
	AT	Teschner: "Offsettechnik", 5. Auflage, Felbach, Fachschriften-Verlag 1983, p. 193-202 and S. 350						
	AU	From Cathode Rays to Digital Micromirrors: A History of Electronic Projection Display Technology Larry J. Hornbeck - July-September 1998						
	AV							
Examiner 		Date Considered 11/10/2005						
<p>*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.</p>								